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Inventor Information for 10/790049

Inventor Name	City	State/Country
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		magnetic layer pattern			
US 6729013 B2	20040504	Method of manufacturing thin-film magnetic head	29/603.07	29/603.11; 29/603.13; 29/603.15; 29/603.17; 360/126; 360/317	Sasaki; Yoshitaka
US 6729012 B1	20040504	Method of manufacturing a thin-film magnetic head	29/603.07	29/603.14; 29/603.23; 29/603.24; 360/119; 360/126; 360/318	Sasaki; Yoshitaka
US 6721140 B2	20040413	Magnetoresistive device and method of manufacturing same and thin-film magnetic head and method of manufacturing same	360/323	360/320	Inoue; Tohru et al.
US 6718623 B2	20040413	Magnetoresistive device and method of manufacturing same, and thin-film magnetic head and method of manufacturing same	29/603.14	29/603.18; 360/322	Sasaki; Yoshitaka et al.
US 6712984 B2	20040330	Method of manufacturing thin film magnetic head	216/22	29/603.07; 29/603.12; 29/603.13; 29/603.15; 29/603.16	Sasaki; Yoshitaka
US 6698686 B2	20040302	Airship	244/30	244/31; 244/96; 244/97	Ogawa; Daihachi et al.
US 6697220 B2	20040224	Thin film magnetic head	360/126		Sasaki; Yoshitaka
US 6687096 B2	20040203	Thin-film magnetic head and method of manufacturing same	360/317	360/126	Sasaki; Yoshitaka et al.
US 6680815 B2	20040120	Thin film magnetic head and method of manufacturing the same	360/126	360/313	Sasaki; Yoshitaka
US 6678942 B1	20040120	Thin film magnetic head and method of manufacturing the same	29/603.25	29/603.14; 29/603.15; 29/603.27; 360/123	Sasaki; Yoshitaka
US 6673633	20040106	Method of forming	438/3	360/126;	Sasaki;

B2		patterned thin film and method of manufacturing thin-film magnetic head		360/313; 360/317; 360/319; 438/712; 438/720; 438/734	Yoshitaka
US 6671135 B2	20031230	Thin film magnetic head recessed partially into substrate and including planarization layers	360/317	360/121; 360/126	Sasaki; Yoshitaka et al.
US 6671134 B1	20031230	Thin film magnetic head and method of manufacturing the same	360/317	360/234.5	Sasaki; Yoshitaka
US 6671133 B1	20031230	Thin-film magnetic head and method of manufacturing same	360/317	360/322	Sasaki; Yoshitaka
US 6669855 B2	20031230	Method of manufacturing thin film magnetic head	216/22	29/603.13; 29/603.15; 29/603.18	Sasaki; Yoshitaka et al.
US 6668442 B2	20031230	Method of manufacturing a thin film magnetic head	29/603.14	29/603.11; 29/603.13; 29/603.15; 29/603.16; 29/603.17; 360/126; 360/317; 451/41; 451/5	Sasaki; Yoshitaka
US 6667849 B2	20031223	Thin film magnetic head and the manufacturing method	360/126		Sasaki; Yoshitaka et al.
US 6660342 B1	20031209	Pulsed electromagnetic energy method for forming a film	427/571	118/723MA; 118/723MP; 118/723MR; 118/723MW; 427/249.15; 427/249.7; 427/255.38; 427/255.391; 427/255.392; 427/255.394; 427/569; 427/575; 427/576; 427/577; 427/578	Miyanaga; Akiharu et al.

US 6657815 B1	20031202	Thin film magnetic head and method of manufacturing the same	360/126		Sasaki; Yoshitaka
US 6651312 B1	20031125	Method for manufacturing a composite type thin film magnetic head having normal structure	29/603.12	29/603.13; 29/603.15; 29/603.18; 360/313	Sasaki; Yoshitaka
US 6646829 B2	20031111	Slider materials	360/126	29/603.19; 360/234.3	Sasaki; Yoshitaka et al.
US 6646828 B1	20031111	Thin film magnetic head and method of manufacture the same	360/126		Sasaki; Yoshitaka
US 6643095 B1	20031104	Thin-film magnetic head having a thin-film coil and method of manufacturing same	360/126		Sasaki; Yoshitaka
US 6633463 B1	20031014	Thin-film magnetic head, head suspension assembly, magnetic disk device and manufacturing method of them	360/320		Inoue; Tohru et al.
US 6631550 B2	20031014	Method of manufacturing a thin-film magnetic head	29/603.14	29/603.13; 29/603.24; 360/319	Sasaki; Yoshitaka
US 6624971 B1	20030923	Thin film magnetic head and method of manufacturing the same	360/126		Sasaki; Yoshitaka
US 6624970 B1	20030923	Thin-film magnetic head having an induction-type magnetic transducer and method of manufacturing same	360/126		Sasaki; Yoshitaka
US 6622371 B2	20030923	Method of manufacturing thin film magnetic head	29/603.14	29/603.11; 29/603.13; 29/603.15; 29/603.16; 29/605; 29/606; 451/41; 451/5	Sasaki; Yoshitaka
US 6614107 B2	20030902	Thin-film heat sink and method of manufacturing same	257/706	257/625; 257/675; 257/712;	Inoue; Tohru et al.

				257/717; 257/720; 257/796; 257/E23.106	
US 6609291 B1	20030826	Method of manufacturing a thin film magnetic head	29/603.14	29/603.07; 29/603.15; 29/603.23; 360/126	Sasaki; Yoshitaka et al.
US 6605196 B2	20030812	Method of forming magnetic layer pattern and method of manufacturing thin film magnetic head	204/192.12	205/122; 205/255; 205/90; 205/922; 216/22; 216/38; 216/39; 216/52; 216/67; 427/130; 427/131; 427/355; 427/402; 451/29	Sasaki; Yoshitaka
US 6603641 B1	20030805	Thin film magnetic head and method of manufacturing the same	360/317	29/603.24; 360/123	Sasaki; Yoshitaka
US 6598289 B1	20030729	Method of manufacturing thin-film magnetic head	29/603.15	29/603.13; 29/603.16; 360/126; 451/41; 451/5	Sasaki; Yoshitaka
US 6583954 B1	20030624	Thin-film magnetic head and method of manufacturing same	360/126		Sasaki; Yoshitaka
US 6581271 B2	20030624	Method of manufacturing thin-film magnetic head	29/603.09	29/593; 29/603.01; 29/603.1	Sasaki; Yoshitaka et al.
US 6578252 B2	20030617	Method of manufacturing a thin film magnetic head	29/603.12	216/22; 216/38; 216/52; 29/603.11; 29/603.13; 29/603.16; 29/603.23; 360/122; 360/123; 360/126	Sasaki; Yoshitaka

US 6577475 B1	20030610	Thin-film magnetic head having reduced yoke length and method of manufacturing same	360/317	29/603.14; 360/126	Sasaki; Yoshitaka et al.
US 6560068 B1	20030506	Thin-film magnetic head including two stacked pole portion layers of equal widths, and method of manufacturing same	360/126		Sasaki; Yoshitaka
US 6558561 B2	20030506	Thin film magnetic head and method of manufacturing the same	216/22	29/603.14; 29/603.15; 438/3	Sasaki; Yoshitaka
US 6557241 B1	20030506	Method of manufacturing combination type thin film magnetic head and wafer for use therefor	29/603.12	29/603.09; 29/603.1; 29/603.14; 29/603.15; 29/603.23; 360/126; 360/317; 451/5; 451/8	Sasaki; Yoshitaka
US 6542339 B1	20030401	Inverted hybrid thin film magnetic head and method of manufacturing the same	360/317		Sasaki; Yoshitaka et al.
US 6541065 B1	20030401	Thin-film magnetic head and method of manufacturing same	427/130	427/131; 427/132; 427/264; 427/265; 427/270; 427/271; 427/331; 427/402; 427/404	Sasaki; Yoshitaka et al.
US 6525905 B1	20030225	Thin film magnetic head having a non-magnetic body and method of manufacturing the same	360/126	360/123	Sasaki; Yoshitaka
US 6525904 B1	20030225	Thin film magnetic head with precisely controlled pole width and method of manufacturing same	360/126	360/317	Sasaki; Yoshitaka
US 6525903 B1	20030225	Thin-film magnetic head and method of manufacturing same	360/126	29/603.14; 360/317	Sasaki; Yoshitaka
US 6519834	20030218	Method of	29/603.14	29/603.15;	Sasaki;

B1		manufacturing thin-film magnetic head		29/603.16	Yoshitaka
US 6513229 B1	20030204	Method of manufacturing slider materials, method of manufacturing sliders, and slider materials	29/603.19	360/234.3	Sasaki; Yoshitaka et al.
US 6504686 B1	20030107	Thin-film magnetic head including a non-magnetic layer for reducing noise in a reproducing head, and method of manufacturing same	360/317	360/319	Sasaki; Yoshitaka
US 6490130 B2	20021203	Thin film magnetic head with recess for positional reference	360/126	360/122	Sasaki; Yoshitaka et al.
US 6490127 B1	20021203	Thin film magnetic head with diverging pole connection portions	360/126		Sasaki; Yoshitaka
US 6490126 B1	20021203	Thin-film magnetic head having a magnetic layer including stacked magnetic material layers and a resistance layer and method of manufacturing same	360/126		Sasaki; Yoshitaka
US 6483665 B1	20021119	Thin film magnetic head and method of manufacturing same	360/126	29/603.14	Sasaki; Yoshitaka
US 6477005 B1	20021105	Thin-film magnetic head having a magnetic layer including an auxiliary layer made of a high saturation flux density material and method of manufacturing same	360/126	360/317	Sasaki; Yoshitaka
US 6477004 B2	20021105	Thin film magnetic head	360/123		Sasaki; Yoshitaka
US 6470565 B1	20021029	Method of manufacturing slider of thin-film magnetic head	29/603.12	29/603.18; 360/235.4	Sasaki; Yoshitaka
US 6469876 B1	20021022	Thin-film magnetic head and method of manufacturing same	360/317	360/126	Sasaki; Yoshitaka et al.
US 6462915	20021008	SYSTEM AND	360/317	360/320	Sasaki;

B1		METHOD FOR MANUFACTURING A COMPOSITE TYPE THIN FILM MAGNETIC HEAD HAVING A READING MAGNETORESISTIVE EFFECTIVE TYPE THIN FILM MAGNETIC HEAD AND A WRITING INDUCTIVE TYPE THIN FILM MAGNETIC HEAD THAT ARE STACKED			Yoshitaka
US 6459543 B1	20021001	Thin-film magnetic head with helical wound coil	360/126		Sasaki; Yoshitaka
US 6456459 B1	20020924	Thin-film magnetic head and method of manufacturing same	360/126	360/317	Sasaki; Yoshitaka
US 6452756 B1	20020917	Thin-film magnetic head and method of manufacturing same and thin-film magnetic head material and method of manufacturing same	360/317	29/603.14; 360/126; 360/319	Sasaki; Yoshitaka
US 6452743 B1	20020917	Thin-film magnetic head having a magnetic layer that defines a throat height and a magnetic layer that defines a track width and method of manufacturing same	360/126	360/317	Sasaki; Yoshitaka
US 6441995 B1	20020827	Thin film magnetic head and method of manufacturing same	360/126		Sasaki; Yoshitaka
US 6433960 B1	20020813	Method of manufacturing a magnetic head	360/123	360/126	Sasaki; Yoshitaka
US 6430003 B1	20020806	Thin film magnetic head and method of manufacturing same	360/126	29/603.15	Sasaki; Yoshitaka
US 6419845 B1	20020716	Method of etching magnetic layer, of forming magnetic pole of thin film magnetic	216/22	216/58; 216/63; 216/66; 216/74;	Sasaki; Yoshitaka

		head and of manufacturing thin film magnetic head		216/75; 216/76; 216/77; 29/603.13; 29/603.15; 29/603.18; 360/324	
US 6414824 B1	20020702	Thin film magnetic head having a shield layer adjacent a gap layer and method of manufacturing the same	360/317	360/126; 360/319	Sasaki; Yoshitaka
US 6404602 B2	20020611	Combination type thin film magnetic head having a stepped magnetic layer	360/317		Sasaki; Yoshitaka
US 6400525 B1	20020604	Thin-film magnetic head and method of manufacturing same	360/123		Sasaki; Yoshitaka et al.
US 6392852 B1	20020521	Thin-film magnetic head and method of manufacturing same, and magnetoresistive device	360/320		Sasaki; Yoshitaka
US 6388845 B1	20020514	Thin film magnetic head and method of manufacturing the same	360/317	360/126	Sasaki; Yoshitaka
US 6387285 B1	20020514	Method of manufacturing thin-film magnetic head	216/38	216/18; 216/22; 216/53; 360/313; 360/319; 360/320	Sasaki; Yoshitaka
US 6385012 B1	20020507	Thin-film magnetic head and method of manufacturing same and thin-film magnetic head material and method of manufacturing same	360/234.5		Sasaki; Yoshitaka
US 6374479 B1	20020423	Method and apparatus for manufacturing slider	29/603.16	29/412; 29/414; 29/417; 29/423; 29/424; 29/603.12	Sasaki; Yoshitaka et al.
US 6353995	20020312	Thin film mangetic head	29/603.14	360/317	Sasaki;

B1		and method of manufacturing same			Yoshitaka et al.
US 6342990 B1	20020129	Method for forming magnetic pole layer of thin film magnetic head, thin film magnetic head and method for manufacturing the same	360/126		Sasaki; Yoshitaka
US 6339670 B1	20020115	Digital VTR	386/68	386/79; 386/80; 386/81	Ueda; Tomohiro et al.
US 6333841 B1	20011225	Thin film magnetic head and method of manufacturing the same	360/317	360/126	Sasaki; Yoshitaka
US 6330743 B1	20011218	Thin film magnetic head and method of manufacturing the same	29/603.14	216/22; 29/603.15; 29/603.18; 360/328	Iijima; Atsushi et al.
US 6330127 B1	20011211	Thin film magnetic head and method of manufacturing same	360/126	29/603.14	Sasaki; Yoshitaka
US 6320726 B1	20011120	Thin film magnetic head and method of manufacturing the same, and method of forming thin film coil	360/126	360/123	Sasaki; Yoshitaka
US 6317300 B1	20011113	Magnetoresistive device having magnetoresistive film and magnetic bias film with side-end faces with different angles of inclination and having insulating film made of electrically insulating material	360/325	257/E43.004	Sasaki; Yoshitaka et al.
US 6317289 B1	20011113	Combination-type thin film magnetic head with improved writing properties	360/126		Sasaki; Yoshitaka
US 6317288 B1	20011113	Thin-film magnetic head and method of manufacturing same	360/126	360/317	Sasaki; Yoshitaka
US 6315875 B1	20011113	Method of manufacturing thin-film magnetic head and method of	204/192.34	204/192.35; 216/22; 216/66	Sasaki; Yoshitaka

		manufacturing magnetoresistive device			
US 6301077 B1	20011009	Thin film magnetic head and method of manufacturing the same	360/126		Sasaki; Yoshitaka
US 6296776 B1	20011002	Method of manufacturing a combination type thin film magnetic head	216/22	216/72; 29/603.18; 360/126; 360/313	Sasaki; Yoshitaka
US 6285532 B1	20010904	Thin-film magnetic head and method of manufacturing same and thin-film magnetic head sub-structure and method of manufacturing same	360/317		Sasaki; Yoshitaka
US 6278580 B1	20010821	Composite type thin film magnetic head that includes a pole chip and a top pole and an insulating layer that acts as an etching stopper during anisotropic etching	360/126	360/120; 360/317	Sasaki; Yoshitaka
US 6274222 B1	20010814	Thin-film magnetic head material and method of manufacturing same and method of manufacturing thin-film magnetic head	428/141	360/313; 428/815; 428/900	Sasaki; Yoshitaka et al.
US 6266868 B1	20010731	Method of manufacturing a combination thin film magnetic head	29/603.1	29/603.12; 29/603.14; 29/603.25	Sasaki; Yoshitaka
US 6260256 B1	20010717	Method of manufacturing a magnetic head	29/603.01	29/603.11; 29/603.12	Sasaki; Yoshitaka
US 6259585 B1	20010710	Inverted hybrid thin film magnetic head and method of manufacturing the same	360/317		Sasaki; Yoshitaka et al.
US 6255040 B1	20010703	Method of manufacturing thin film magnetic head	430/320	29/603.07; 430/315; 430/319; 430/396	Sasaki; Yoshitaka
US 6233813	20010522	Method of	29/603.14	216/22;	Sasaki;

B1		manufacturing thin film head		29/603.15; 29/603.18	Yoshitaka et al.
US 6212033 B1	20010403	Slider and method for manufacturing the same	360/230	216/47; 360/220; 430/320	Sasaki; Yoshitaka
US 6204997 B1	20010320	Thin film magnetic head with a plurality of engaged thin-film coils and method of manufacturing the same	360/123	360/126	Sasaki; Yoshitaka
US 6195872 B1	20010306	Method of manufacturing a thin film magnetic head	29/603.13	216/22; 216/94; 29/603.14; 29/603.15; 29/603.18; 29/603.24; 360/318; 360/319; 360/320; 427/129; 427/132	Sasaki; Yoshitaka
US 6191916 B1	20010220	Thin film magnetic head and method of manufacturing the same	360/126	360/123	Sasaki; Yoshitaka
US 6163436 A	20001219	Thin film magnet head with improved performance	360/126	360/123	Sasaki; Yoshitaka et al.
US 6154347 A	20001128	Combination type thin film magnetic head and method of manufacturing the same	360/317		Sasaki; Yoshitaka
US 6154346 A	20001128	Composite type thin film magnetic head having normal structure including inductive type thin film magnetic head and magnetoresistive type thin film magnetic head	360/317		Sasaki; Yoshitaka
US 6134061 A	20001017	Digital signal recording and reproducing apparatus and digital signal recording and reproducing method collectively recording inspecton codes and	360/48	360/53; 386/124; 386/40; 714/755	Inoue; Tohru et al.

		forming a gap therebetween during post-scoring			
US 6130805 A	20001010	Thin film magnetic head having upper pole chip formed over insulating layer	360/126		Sasaki; Yoshitaka et al.
US 6110542 A	20000829	Method for forming a film	427/577	427/122; 427/249.7; 427/249.8; 427/571; 427/572; 427/575; 427/576; 427/578; 427/902; 427/904	Miyanaga; Akiharu et al.
US 6085022 A	20000704	Digital VTR for recording special replay video data in track areas designated for digital video and digital audio	386/68	386/111; 386/81; 386/96	Ueda; Tomohiro et al.
US 6081649 A	20000627	Digital VTR for processing intra-picture data according to replay modes	386/81	386/111	Asamura; Masako et al.
US 6076252 A	20000620	Method of manufacturing combination type thin film magnetic head	29/603.1		Sasaki; Yoshitaka
US 5960150 A	19990928	Digital VTR	386/68	386/111; 386/81	Ueda; Tomohiro et al.
US 5845041 A	19981201	Video signal recording and reproducing apparatus with high efficiency encoding	386/68	386/109	Ohkuma; Ikuo et al.
US 5825971 A	19981020	Magnetic head replacement structure in helical scan magnetic recording and reproducing apparatus and method thereof	386/122	360/22; 360/64; 386/46	Inoue; Tohru et al.
US 5712861 A	19980127	Error correcting method and decoder with improved reliability	714/752	714/755	Inoue; Tohru et al.

US 5684915 A	19971104	Digital VTR for recording special replay data with appended error correction codes	386/68	386/111; 386/124	Ueda; Tomohiro et al.
US 5627099 A	19970506	Method of manufacturing semiconductor device	438/488	257/E21.258; 438/228; 438/452; 438/911	Sasaki; Yoshitaka
US 5626922 A	19970506	Plasma processing method	427/535	427/249.15; 427/250; 427/255.31; 427/255.38; 427/255.394; 427/294; 427/299; 427/444; 427/539; 427/547; 427/553; 427/571; 427/574; 427/576; 427/578; 427/585; 427/598	Miyanaga; Akiharu et al.
US 5619315 A	19970408	Fixing apparatus using a coated elastic member for use in an image forming apparatus	399/324		Kusumoto; Yasuhiro et al.
US 5587803 A	19961224	Digital signal recording and reproducing apparatus and error-correcting apparatus	386/33	375/240.2; 375/240.24; 714/752	Inoue; Tohru et al.
US 5549780 A	19960827	Method for plasma processing and apparatus for plasma processing	156/345.39	118/723E; 156/345.43	Koinuma; Hideomi et al.
US 5537429 A	19960716	Error-correcting method and decoder using the same	714/755	714/757; 714/782; 714/784	Inoue; Tohru
US 5519547 A	19960521	Magnetic recording and reproducing apparatus recording and reproducing plural types of data signals at different data rates	360/64	386/109	Yamasaki; Tatsuo et al.

US 5400186 A	19950321	Apparatus and method for recording and reproducing digital signals by error-correcting-encoding of video and audio signals collectively	360/32	386/100	Inoue; Tohru et al.
US 5371750 A	19941206	Error-correction encoding and decoding system	714/755		Inoue; Tohru et al.
US 5360477 A	19941101	Method for forming diamond and apparatus for forming the same	117/4	117/5; 117/904; 117/929	Inoue; Tohru et al.
US 4897839 A	19900130	Coding and decoding method	714/785		Yamagishi; Atsuhiko et al.
US 4841300 A	19890620	Error correction encoder/decoder	341/94	341/51; 714/785	Yoshida; Hideo et al..
US 4833513 A	19890523	MOS FET semiconductor device having a cell pattern arrangement for optimizing channel width	257/342	257/E21.418; 257/E29.027; 257/E29.066; 257/E29.257	Sasaki; Yoshitaka
US 4627813 A	19861209	Thermal fixing apparatus	432/60	219/216; 399/335	Sasaki; Yoshitaka
US 4625391 A	19861202	Semiconductor device and method for manufacturing the same	438/625	148/DIG.117; 148/DIG.122; 148/DIG.8; 257/384; 257/506; 257/574; 257/587; 257/755; 257/758; 257/E21.165; 257/E21.296; 257/E21.316; 257/E21.438; 257/E21.507; 257/E21.59; 257/E21.592; 438/586; 438/588; 438/595; 438/635; 438/639	Sasaki; Yoshitaka

US 4592054 A	19860527	Decoder with code error correcting function	714/761		Namekawa; Toshihiko et al.
US RE32126 E	19860429	Toner image pressure-fixing device	100/158R	118/116; 399/339; 430/98	Sasaki; Yoshitaka
US 4566778 A	19860128	Pressure fixing device	399/339	219/216; 399/322	Sasaki; Yoshitaka
US 4521448 A	19850604	Method of manufacturing semiconductor device	438/586	257/E21.039; 257/E21.3; 257/E21.589; 257/E23.164; 257/E29.146; 257/E29.255; 427/259; 438/595; 438/596; 438/669	Sasaki; Yoshitaka
US 4521184 A	19850604	Pressure fixing device	432/60	399/327; 432/75	Samuels; Abe et al.
US 4471525 A	19840918	Method for manufacturing semiconductor device utilizing two-step etch and selective oxidation to form isolation regions	438/431	257/397; 257/398; 257/510; 257/640; 257/648; 257/E21.258; 257/E21.3; 257/E21.546; 257/E21.547; 257/E21.553; 257/E21.554; 438/436; 438/445; 438/944	Sasaki; Yoshitaka
US 4433470 A	19840228	Method for manufacturing semiconductor device utilizing selective etching and diffusion	438/323	257/513; 257/555; 257/574; 257/622; 257/E21.033; 257/E21.151; 257/E21.538; 257/E21.553; 438/359; 438/426	Kameyama; Shuichi et al.
US 4426411 A	19840117	Method of fabricating a steel pressure roll for	427/349	205/222	Sasaki; Yoshitaka et

		use in a pressure-fixation apparatus			al.
US 4407059 A	19831004	Method of producing semiconductor device	438/301	257/E21.151; 257/E21.301; 257/E21.433; 257/E21.608; 257/E29.173; 438/323; 438/365; 438/586	Sasaki; Yoshitaka
US 4343234 A	19820810	Pressure-fixation apparatus	100/158R	118/116; 399/339	Sasaki; Yoshitaka
US 4259920 A	19810407	Toner image pressure-fixing device	118/116	100/158R; 399/339; 430/98	Sasaki; Yoshitaka
US 4119442 A	19781010	Process for manufacturing a steel product	148/500	72/365.2	Nagumo; Michihiko et al.
US RE28645 E	19751209	Method of heat-treating low temperature tough steel	148/621	148/653; 148/662; 148/663	Aoki; Koichi et al.
US 3619302 A	19711109	METHOD OF HEAT-TREATING LOW TEMPERATURE TOUGH STEEL	148/621	148/622; 148/653; 148/662; 148/663	Aoki; Koichi et al.